



**RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 1765**

PATENT
Attorney Docket No. 98124X205843
LVM Reference No. 205843

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Wang et al.

Application No. 09/636,246

Art Unit: 1765

Examiner: Kin Chan Chen

Filed: August 10, 2000

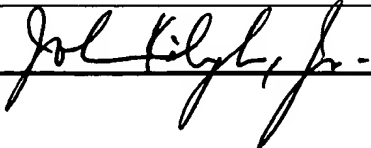
For: POLISHING SYSTEM WITH
STOPPING COMPOUND AND
METHOD OF ITS USE

RESPONSE TO OFFICE ACTION

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated December 1, 2003, please consider the following remarks.

| CERTIFICATE OF MAILING UNDER 37 CFR 1.10 | | | |
|---|---|------|--------------|
| I hereby certify that this Response to Office Action and all accompanying documents are being deposited with the United States Postal Service on June 1, 2004, in an envelope as "EXPRESS MAIL POST OFFICE TO ADDRESSEE" service under 37 CFR 1.10, Mailing Label Number EV 419246029 US, addressed to: Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450. | | | |
| Name (Print/Type) | John Kilyk, Jr. | | |
| Signature |  | Date | June 1, 2004 |

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